



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 2748

SERIAL NUMBER 10/806,521	FILING DATE 03/23/2004 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 5649-1226
-----------------------------	---------------------------------------	--------------	------------------------	-------------------------------------

APPLICANTS

Won-Jin Kim, Gyeonggi-do, KOREA, REPUBLIC OF;
 Young-Wook Park, Gyeonggi-do, KOREA, REPUBLIC OF;
 Jeong-Do Ryu, Gyeonggi-do, KOREA, REPUBLIC OF;

** CONTINUING DATA *****
None WLL

** FOREIGN APPLICATIONS *****
 REPUBLIC OF KOREA 2003-18275 03/24/2003 *WLL*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 08/25/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>WLL</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 9	TOTAL CLAIMS 22	INDEPENDENT CLAIMS 4
--	--	---	------------------------	-----------------------	----------------------------

ADDRESS
 Laura M. Kelley
 Myers Bigel Sibley & Sajovec, P.A.
 P.O. Box 37428
 Raleigh, NC
 27627

TITLE
 Methods of fabricating a semiconductor substrate for reducing wafer warpage

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
------------	---	--